

INFORMATION DISCLOSURE CITATION

Atty. Docket No.	04329.2722	Serial No.	<u>10/026,566</u> <u>Not Assigned</u>
Applicant	Hiroshi KUBOTA et al.		
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FOREIGN PATENT DOCUMENTS							
		Document Number	Publication Date	Country	Class	Sub Class	Translation Yes or No
Gw		10-122178	5/12/98	Japan			Abstract
		6-327924	11/29/94	Japan			Abstract
Gw		9-251981	9/22/97	Japan			Abstract

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	
<i>Gud</i>	Itsuko SAKAI et al., "SEMICONDUCTOR PROCESSING APPARATUS AND METHOD FOR MANUFACTURING A SEMICONDUCTOR DEVICE", Serial No. 09/955,083 filed September 19, 2001.
<i>Gud</i>	Masashi SAITO et al., " PROCESSING APPARATUS", Serial No. 09/686,370 filed October 12, 2000.

Examiner <u>George L. Walton</u>	Date Considered <u>3/22/04</u>
<p>*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>	